



Attorney Docket: 67,200-1120
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jia-Ren Chen, et al

Serial No.: 10./684,855

Filed: 10/14/2003

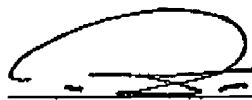
Examiner: Nguyen, Thanh T.

For Multiple Gate Electrode Linewidth Measurement and Photoexposure Compensation Method

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certified that this correspondence is (1) ☐ being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on May 22, 2006; or (2) ☒ being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571)-273-8300 on May 22, 2006.

Randy W. Tung
Printed Name


Signature

5/22/06
Date

Please forward all correspondence to
TUNG & ASSOCIATES
838 W. Long Lake Road, Suite 120
Bloomfield Hills, MI 48302

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Commissioner for Patents
P.O. Box 1450
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PETITION UNDER 37 CFR 1.177

Dear Sir:

The Applicants are hereby requesting to defer the issuance of the herein referenced patent for a period of at least three (3) months to allow the adding of a foreign inventor who was omitted from the original filing. The Applicants have requested the signatures on the appropriate documentation, however, because the inventor and the

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Applicants are in a foreign country, it is necessary to delay the issuance of the patent until the inventor's name is corrected and added on the Assignment.

WHEREFORE, your Applicants request that this patent application defer is issuance for a period of three (3) months.

Respectfully submitted


Randy W. Tung,
Registration No. 31311
Tung and Associates
838 W. Long Lake Rd, Suite 120
Bloomfield Hills, MI 48302
(248) 540-4040